

STATEMENT UNDER 37 CFR 3.73(b)

Atty. Docket No. 1857.6850000

Applicant/Patent Owner: HEON et al.

Application No./Patent No.: 6,746,826 Filed/Issue Date: June 8, 2004

Entitled: Method for an Improved Developing Process in Wafer Photolithography

ASML Holding N.V.

, a

corporation

(Name of Assignee)

(Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)

states that it is:

1. ☒ the assignee of the entire right, title, and interest; or
2. ☐ an assignee of less than the entire right, title and interest
(The extent (by percentage) of its ownership interest is _____ %)

in the patent application/patent identified above by virtue of either:

- A. ☐ An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel _____, Frame _____, or for which a copy therefore is attached.

OR

- B. ☒ A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as follows:

1. From: HEON et al. To: Silicon Valley Group, Inc.

The document was recorded in the United States Patent and Trademark Office at

Reel 011500, Frame 0094, or for which a copy thereof is attached.

2. From: Silicon Valley Group, Inc. To: ASML US, Inc.

The document was recorded in the United States Patent and Trademark Office at

Reel 021360, Frame 0168, or for which a copy thereof is attached.

3. From: SVG Lithography Systems, Inc. To: ASML US, Inc.

The document was recorded in the United States Patent and Trademark Office at

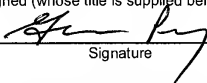
Reel 021360, Frame 0189, or for which a copy thereof is attached.

- ☒ Additional documents in the chain of title are listed on a supplemental sheet.

- ☒ As required by 37 CFR 3.73(b)(1)(i), the documentary evidence of the chain of title from the original owner to the assignee was, or concurrently is being, submitted for recordation pursuant to 37 CFR 3.11.

[NOTE: A separate copy (i.e., a true copy of the original assignment document(s)) must be submitted to Assignment Division in accordance with 37 CFR Part 3, to record the assignment in the records of the USPTO. See MPEP 302.08]

The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.


Signature

November 24, 2008

Date

Glenn J. Perry, Reg. No. 28,458

Printed or Typed Name

(202) 371-2600

Telephone Number

Authorized Agent

Title

Statement Under 37 CFR 3.73(b) (PTO/SB/96)
Supplemental Sheet for Chain of Title, Item B

Applicant/Owner: HEON et al.

Application No./Patent No.: 6,746,826

Application Date/Issue Date: June 8, 2004

Title: **Method for an Improved Developing Process in Wafer Photolithography**

Name of Assignee: **ASML Holding N.V.**

Type of Assignee: **corporation**

Part B Continued: Additional Documents in the Chain of Title

4. From: ASML US, Inc. To: ASML US, LLC
The document was recorded in the United States Patent and Trademark Office at
Reel 021360, Frame 0088, or for which a copy thereof is
attached.
5. From: ASML US, LLC To: ASML US, Inc.
The document was recorded in the United States Patent and Trademark Office at
Reel 021360, Frame 0092, or for which a copy thereof is
attached.
6. From: ASML US, Inc. To: ASML Holding N.V.
The document was recorded in the United States Patent and Trademark Office at
Reel 021872, Frame 0047, or for which a copy thereof is
attached.
7. From: _____ To: _____
The document was recorded in the United States Patent and Trademark Office at
Reel _____, Frame _____, or for which a copy thereof is
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